

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|             |                             |           |              |
|-------------|-----------------------------|-----------|--------------|
| Applicants: | Young Ho BAE                | Conf.:    | 3483         |
| Appl No:    | 10/029,035                  | Art Unit: | 1792         |
| Filed:      | December 28, 2001           | Examiner: | R. N. KACKAR |
| For:        | VACUUM DEPOSITION APPARATUS |           |              |

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated November 16, 2007, please amend this application as follows.

This paper includes:

**Amendments to the Specification;**

**Amendments to the Drawings;**

**Amendments to the Claims; and**

**Remarks/Arguments.**

*Entered w/RCE dated 5/15/08.*

*LW  
5/16/08*